#### APPLIED SCIENCES AND ENGINEERING

# One-step rolling fabrication of VO<sub>2</sub> tubular bolometers with polarization-sensitive and omnidirectional detection

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Uncooled infrared detection based on vanadium dioxide (VO<sub>2</sub>) radiometer is highly demanded in temperature monitoring and security protection. The key to its breakthrough is to fabricate bolometer arrays with great absorbance and excellent thermal insulation using a straightforward procedure. Here, we show a tubular bolometer by one-step rolling VO<sub>2</sub> nanomembranes with enhanced infrared detection. The tubular geometry enhances the thermal insulation, light absorption, and temperature sensitivity of freestanding VO<sub>2</sub> nanomembranes. This tubular VO<sub>2</sub> bolometer exhibits a detectivity of  $\sim 2 \times 10^8$  cm Hz<sup>1/2</sup> W<sup>-1</sup> in the ultrabroad infrared spectrum, a response time of  $\sim 2.0$  ms, and a calculated noise-equivalent temperature difference of 64.5 mK. Furthermore, our device presents a workable structural paradigm for polarization-sensitive and omnidirectional light coupling bolometers. The demonstrated overall characteristics suggest that tubular bolometers have the potential to narrow performance and cost gap between photon detectors and thermal detectors with low cost and broad applications.

#### INTRODUCTION

Infrared photodetectors are widely applied in our daily life, such as remote thermometer (1, 2), environmental monitoring (3, 4), and personal search and rescue in geological disasters (5, 6). Uncooled infrared detection technology is increasingly being developed to meet the portability of daily monitoring and the capability for various application scenarios. To achieve high sensitivity and intensity, uncooled infrared detectors comprise a heat-sensitive suspended layer or structure on a wafer with excellent thermal insulation and enhanced signal collection (7). Advances in microfabrication technology have enabled the manufacture of uncooled infrared thermal detectors with various structures such as cantilever (8, 9)and antennas (10, 11), in addition to the established pellicle-supported and microbridge structures. Uncooled focal plane arrays based on bolometers, pyroelectric detectors, and thermopiles have reached a noise-equivalent temperature difference (NETD) of less than 0.1 K (12), which have been implemented in the night vision systems and infrared cameras. A bolometer based on polycrystalline vanadium oxide nanomembrane (13-15) is achieved with high temperature coefficient of resistance (TCR) and good processability for uncooled thermal imaging devices (16). However, complicated structures to improve the thermal insulation and signal enhancement require a multiple-step process in the microfabrication (17-

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19), which thus increases system complexity and manufacturing cost with low yield (20, 21). Furthermore, the portable polarimetry and wide-angle infrared imaging system, which operates without the need for lenses, offers advantages and extensive application opportunities in identifying detection targets amidst complicated environments such as smoke, haze, and camouflage. However, its production presents challenges.

Here, we report a sensitive tubular vanadium dioxide (VO<sub>2</sub>) bolometer fabricated by one-step rolling for polarization-sensitive and omnidirectional infrared detection. Rolled-up nanomembrane technology can be combined with existing chip fabrication methods to convert specified VO<sub>2</sub> precursor planar nanomembranes into microtubes with three-dimensional (3D) geometries. Theoretical simulation and experimental verification prove that tubular geometry can provide superior thermal insulation and trap infrared light. The atomic structure of the rolled-up VO<sub>2</sub> nanomembrane was investigated by in situ temperature-variable transmission electron microscopy (TEM), with compressive strain that reduces the phase transition temperature from 68° to 40°C. This tubular VO<sub>2</sub> bolometer exhibits a detectivity of  $\sim 2 \times 10^8$  cm Hz<sup>1/2</sup>  $W^{-1}$ , a response time of ~2.0 ms, and a calculated NETD of 64.6 mK over a broad infrared spectrum. Besides, the VO<sub>2</sub> bolometer with tubular geometry can offer polarization-sensitive and omnidirectional detection under a wide incident angle of 150°, which brings vitality to the development of uncooled infrared focal plane technology. More profoundly, our tubular bolometers offer a promising integration platform for photon/electron chips by forming 3D volumetric devices with a more compact footprint.

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#### RESULTS

#### Design methodology of rolled-up tubular bolometers

The structure of the bolometer is directly related to the thermal insulation and light absorption of the nanomembranes. As a typical 3D structure, the tube consists of uniform walls and cylindrical cavities. In an ideal case, the contact between the tube and the plane is a line, which can greatly reduce the direct heat transfer between tube and plane so that a tubular device with high thermal insulation can be realized by occupying much smaller area on the chip. Moreover, the tubular microcavity structure is a typical and effective light trap structure, which can effectively enhance the interaction between the light and the tube wall and improve the absorption of incident rays. Figure 1A schematically depicts the structure of an on-chip tubular bolometer with a thermal sensitive nanomembrane and metal electrodes. The sensitive nanomembrane (i.e., VO<sub>2</sub> nanomembrane in present case) becomes hotter ( $\Delta T$ ) when exposed to infrared light, which causes a resistance drop ( $\Delta R$ ) that can be detected by the circuit ( $\Delta I$ ). The corresponding fabrication process is shown in Fig. 1B. Briefly, VO<sub>2</sub>/Cr bilayer with strain gradient was grown on silicon wafer with silicon dioxide (SiO<sub>2</sub>) sacrificial layer. After the removal of SiO<sub>2</sub> layer, VO<sub>2</sub>/Cr bilayer is detached from the substrate and rolled up because of the strain gradient. Figure 1C shows a  $3 \times 4$ array of the fabricated VO<sub>2</sub>/Cr microtubes. To further demonstrate the thermal insulation and optical coupling mechanism of the tubular bolometer, the thermal distribution in the thermal radiation field and the electromagnetic wave distribution of the optical field were simulated by using COMSOL Multiphysics and finite-difference time-domain (FDTD) simulation, respectively. We compare the heat distribution of the planar and tubular VO<sub>2</sub> nanomembrane under thermal radiation on a thick substrate. The elevated heat of the planar nanomembrane was rapidly transferred directly down from the VO<sub>2</sub> nanomembrane to the substrate. Therefore, the temperature of the planar VO<sub>2</sub> nanomembrane is basically the same as that of the substrate (fig. S1A). However, the temperature of the VO<sub>2</sub> tube on the substrate is higher than that of the substrate, as shown in Fig. 1D. This is because the heat transfers between the VO<sub>2</sub> tube and the substrate is greatly limited. The tubular geometry structure can greatly reduce heat transfer from the thermally sensitive VO<sub>2</sub> nanomembrane to substrate, which is one of the key factors in designing high-performance bolometers (22). Since bolometers often operate in the long-wave infrared spectrum, limited absorption of heat in atomically thin nanomembranes has always been a great challenge (23). Fortunately, the tubular structure can provide an optical microcavity with multiple reflections. During each reflection, a portion of the infrared light is absorbed by the tube wall, and thereby the total absorption in the tubular cavity is remarkably enhanced (24). In Fig. 1E, the optical coupling profile under 8-µm incident light is demonstrated, and an electromagnetic field enhancement is formed inside the chamber of the VO<sub>2</sub> tube (fig. S2). In planar nanomembrane device, however, light passing through the thermosensitive VO<sub>2</sub> nanomembrane will travel along the substrate and will not be reabsorbed (fig. S1B). Therefore, tubular bolometers are more advantageous for ultrabroad infrared spectrum detection.

#### One-step rolling fabrication of VO<sub>2</sub> microtubes

In this work, the VO<sub>2</sub> nanomembrane with a thickness of  $\sim$ 60 nm was sputtered on a 4-inch silicon wafer with 500-nm thermal SiO<sub>2</sub>

by using magnetron sputtering at a substrate temperature of 500°C, as shown in Fig. 2A. The flatness of the as-grown VO<sub>2</sub> nanomembrane was confirmed by atomic force microscopy, and the corresponding root mean square roughness is 2.8 nm over a range of  $30 \times 30 \ \mu\text{m}^2$  (fig. S3). Meanwhile, as a multivalent metal, the valence state of V in the as-grown nanomembranes is proved by Raman spectroscopy (25) and x-ray reflection diffraction (fig. S4) (26, 27). The characteristics of VO<sub>2</sub> metal-insulator phase transition are characterized by temperature-variable Raman spectroscopy (fig. S5) and temperature-variable resistance, as shown in Fig. 2B, and the TCR of the VO<sub>2</sub> nanomembrane at room temperature (RT) is 1.7%  $K^{-1}$  (fig. S6). Furthermore, during the cooling process from growth temperature to RT, strain was introduced into the VO<sub>2</sub> nanomembrane due to the mismatch between thermal expansion coefficients of VO2 and SiO2. As the excitation wavelength increases, the characteristic peaks of VO<sub>2</sub> exhibit red shifts (Fig. 2C), indicating that compressive strain is introduced into the VO<sub>2</sub> Downloaded from nanomembrane (28, 29), and the compressive strain on the  $VO_2$ nanomembrane estimated by Raman spectroscopy is 0.88% (note S1). In the present work, we used the rolled-up technique to fabricate tubular bolometers, and the fabrication process is shown in Fig. 2D: (i) The  $VO_2$  nanomembrane is grown on the substrate by magnetron sputtering. (ii) The 40-nm Cr layer is grown on  $VO_2$  by https://www. e-beam evaporation as additional strain layer and electrode for the bolometer. Then, part of VO<sub>2</sub> is removed by reactive ion etching (RIE) as an etching window. Through photolithography, only the .science.org VO<sub>2</sub> nanomembranes and the etching window are exposed, while the metal pads are protected from hydrofluoric acid solution corrosion by photoresists. (iii) Subsequently, the SiO<sub>2</sub> layer was selectively etched by 10% hydrogen fluoride solution. The VO<sub>2</sub>/Cr layer is at released from the substrate and rolls up into a tubular structure Fudan driven by the strain gradient, as shown in Fig. 2E. Compared with previous microbridge (18, 19) and pellicle-supported (7, 30) struc-University tures, the fabrication process of tubular structure is simpler and costless (figs. S7 and S8). Figure S9 shows the quantitative relationship of the curvature control for the  $VO_2/Cr$  hybrid material system. on Comparison of characteristics and applications of self-rolled tubes October is shown in table S1. The side view of  $VO_2$  tube (Fig. 2F) indicates that the nanomembrane rolls up to form a rounded circle without ,18 slumping. To check the cross section of the sample, a curved  $VO_2/$ Cr bilayer was cut at the top of the tube by focused ion beam etching, along the direction marked by the red line in Fig. 2F, and the sample was removed from the tube (figs. S10 and S11). The cross section of the triple-wall microtubes observed by TEM is shown in Fig. 2G. In this device, thin overlapping layers are observed in highresolution images of the VO<sub>2</sub>/Cr interface and corresponding characteristic element maps are obtained by energy-dispersive x-ray spectroscopy (EDS) (Fig. 2H). A fast growth rate (~0.1 nm/s) is required for growing Cr layer that can provide tensile strain (31). The formation of amorphous alloys at the VO2/Cr interface leads to a large increase in the density of defect states, which may lead to increased device noise, trapped photogenerated carriers, and delayed response time. Furthermore, there is a gap of tens of nanometers between the VO<sub>2</sub>/Cr layers, which does not impair the thermal insulation (fig. S12) and light trapping effects (fig. S13) of the bolometers. Moreover, the VO<sub>2</sub> microtubes undergo slight deformation, resulting in the formation of oval-shaped microtubes, without com-

promising the effectiveness of light trapping (fig. S14).

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Fig. 1. 3D architecture and working principle of tubular bolometers. (A) Perspective-view schematic of the tubular bolometer and its responses to incident infrared light. (B) Illustration of VO<sub>2</sub>/Cr bilayers with compressive strain on silicon wafers before and after removal of SiO<sub>2</sub> sacrificial layer. (C) SEM image of a  $3 \times 4$  array of VO<sub>2</sub>/Cr microtubes. Scale bar, 500  $\mu$ m. (D) Simulation of heat distribution of the microtube under the radiation of a heat source (power, 1 mW). Scale bar, 10  $\mu$ m. (E) Simulation of a vertical incident infrared light (wavelength, 8  $\mu$ m). Scale bar, 10  $\mu$ m.

To explore the metal-insulator phase transition of rolled-up VO<sub>2</sub> nanomembranes, we performed in situ temperature-changing high-resolution atomic phase characteristics on the curved VO<sub>2</sub> nanomembranes. Figure 2I shows the atomic structure of monoclinic VO<sub>2</sub> observed by high-angle annular dark-field–scanning TEM (STEM) at RT. The inset is the corresponding selected-area electron diffraction (SEAD) pattern at the crystallographic axes of [2,  $\overline{1}$ , 1], and the (011) and (11 $\overline{1}$ ) planes are marked in bright colors. The

interplanar spacing of (011) is 0.327 nm, and that of (111) is 0.353 nm. When the temperature is increased from RT to 40°C, the atomic structure of VO<sub>2</sub> transits from monoclinic phase to rutile phase, as shown in Fig. 2J. The inset is the corresponding SEAD pattern with the crystallographic axis directions of  $[1, 1, \overline{3}]$ . The interplanar spacings of (110) and (211) planes (marked in bright colors) are 0.329 and 0.175 nm, respectively. These parameters are highly consistent with standard VO<sub>2</sub> crystals. The atomic



**Fig. 2. Fabrication and characterization of rolled-up VO<sub>2</sub> nanomembrane.** (**A**) Optical image of VO<sub>2</sub> nanomembranes grown on a 4-inch silicon substrate. (**B**) Sheet resistance of the VO<sub>2</sub> nanomembranes as a function of temperature. The lower lines show the abs(slope) of the resistivity. (**C**) Raman spectra of the VO<sub>2</sub> nanomembrane excited by lasers with wavelengths of 633, 532, 514, and 473 nm. a.u., arbitrary units. (**D**) Schematic illustrating the preparation process of VO<sub>2</sub> microtube. (**E**) Focused view of a single microtube. Scale bar, 50 µm. (**F**) Side view of the microtube. (**G**) TEM image of the multilayer VO<sub>2</sub>/Cr microtube wall. Scale bar, 500 nm. (**H**) High-resolution cross-sectional STEM image of the VO<sub>2</sub>/Cr microtube and corresponding elemental distribution. Scale bar, 100 nm. STEM images with corresponding fast Fourier transform patterns and standard atomic structures (O atoms are not shown) of the rolled-up VO<sub>2</sub> nanomembrane at RT (**I**) and 40°C (**J**). Scale bars, 2 nm. (**K**) EELS spectra of monoclinic and rutile VO<sub>2</sub> nanomembranes.

phase crystal structure and lattice parameters change slightly when the in situ temperature is continuously increased to 50°, 60°, 70°, and 80°C (fig. S15). Before and after the VO<sub>2</sub> phase transition, the change of atomic arrangement and SEAD pattern can be seen intuitively (32, 33), which can also be observed in TEM (fig. S16). At RT, the V atoms in the monoclinic  $VO_2$  appear dimerized along the *c* axis with a slight twist, which produces fully occupied bonds  $d_{\parallel}$  and fully empty anti-bonds  $d_{\parallel}^*$ . The Fermi level passes between  $d_{\parallel}^*$  and  $d_{\parallel}$ , resulting in a bandgap of about 0.7 eV (34, 35), so VO<sub>2</sub> exhibits semiconducting properties at low temperature. When the temperature is higher than phase transition temperature,  $VO_2$  of the rutile phase is metallic.  $d_{\parallel}$  overlaps with the  $\pi$  bond, and  $d_{\parallel}$  is penetrated by the Fermi level (fig. S17). The electron energy loss spectrum (EELS) of monoclinic and rutile VO<sub>2</sub> nanomembranes is presented in Fig. 2K. The  $\pi^*$  peak and  $O^*$  peak at the O–K edge of monoclinic  $VO_2$  nanomembranes are relatively flat (32, 36, 37). In addition, the depression after heating represents the appearance of  $d_{\parallel}^*$  in rutile  $\mathrm{VO}_2$  nanomembrane. That is,  $\mathrm{VO}_2$  is transformed from semiconductor phase to metallic phase when temperature rises to 40°C (fig. S17).

## Geometry-dependent thermal insulation of VO<sub>2</sub> nanomembranes

To achieve high response metrics in bolometers, we need a comprehensive understanding of the geometrical dependence of metal insulation phase transition and electrical characteristics of the VO<sub>2</sub> nanomembrane. Previous studies have shown that the metal-insulator phase transition of  $VO_2$  can be regulated by strain, electric field, etc. For instance, compressive (tensile) strain can reduce (increase) the phase transition temperature of VO<sub>2</sub> (31, 38-40). In addition, the reversible metal-insulator phase transition of VO<sub>2</sub> can be directly induced by applying a voltage to generate Joule heat. The dissipation of the Joule heat generated in the VO<sub>2</sub> nanomembrane mainly includes heat conduction to the thick substrate and heat radiation to the atmosphere. Figure 3A shows schematic of an unreleased VO<sub>2</sub> nanomembrane device, and its electrical properties are measured at different substrate temperatures from 25° to 80°C with a 5°C step (Fig. 3D and fig. S18). Current changes were found only when the temperature reached around the normal VO<sub>2</sub> phase transition temperature (~68°C). We extracted the current under 0.1 V at different temperatures (Fig. 3G), which indicates that the Joule heat generated in the unreleased  $VO_2$  nanomembranes is dissipated very quickly, and not sufficient to change the phase transition temperature of VO<sub>2</sub>. After the VO<sub>2</sub> nanomembrane is released, as shown in Fig. 3B, both sides of  $VO_2$  are exposed to the air, and only a small part of the VO<sub>2</sub> nanomembrane is attached to the substrate. As shown in Fig. 3E, applying a voltage less than 5 V can cause the metal-insulator phase transition at RT. We define the voltage at which  $VO_2$  undergoes a metal-insulator phase transition as  $V_{MIT}$ .  $V_{\rm MIT}$  (corresponding to phase transitions from insulation to metal and metal to insulation) at different temperatures (fig. S19) is shown in Fig. 3H, and  $V_{\rm MIT}$  obviously decreases with increasing substrate temperature. When the substrate temperature exceeds 50°C, it is difficult to find a distinguishable  $V_{\rm MIT}$ . This may be caused by the decrease in the phase transition temperature due to the strain in the released VO<sub>2</sub> nanomembranes. These experimental results indicate that the thermal conduction between the released VO<sub>2</sub> and the substrate is greatly reduced, and a metal-insulator

phase transition can occur at lower temperature with voltage driving. It should be noted that at 50°C, V<sub>MIT</sub> increases. This phenomenon can be attributed to two state transitions of VO2 nanofilms under bias voltage/temperature regulation, i.e., planar and bending, which lead to loss of Joule heat. Figure 3C shows that the released VO<sub>2</sub> nanomembrane rolls up into microtube. Compared to the released VO<sub>2</sub> nanomembrane that does not roll into tube, the area of nanomembrane directly exposed to the air in the tube is greatly reduced because of the formation of multilayered walls during self-rolling, as shown in Fig. 2B. In addition, voltagedriven metal to insulation phase transitions of VO<sub>2</sub> can also be realized in tubular devices (Fig. 3F and fig. S20). The  $V_{\text{MIT}}$  required to drive the metal-insulator phase transition of the tubular VO<sub>2</sub> nanomembranes is smaller, which is linearly dependent to temperature (Fig. 3I). No deformation of VO<sub>2</sub> microtubes was observed when the phase transition occurred, indicating that the VO<sub>2</sub> nanomembranes with the tubular structure have excellent thermal insulation, thermal retention properties, and higher mechanical stability. Furthermore, VO<sub>2</sub> microtubes with more winding numbers require a smaller  $V_{\text{MIT}}$  (fig. S21). This is because, under the same heat loss conditions, the tube with more rotations can generate more Joule heat to drive the phase transition of  $VO_2$ .

#### **Optoelectronic characteristics of tubular VO<sub>2</sub> bolometers**

We investigated the absorbance of the VO<sub>2</sub> microtubes, and the result displays strong temperature dependence. In the experiment, the VO<sub>2</sub> nanomembrane was transferred to GaF<sub>2</sub> substrate for in situ variable temperature Fourier transform infrared (FTIR) test (fig. S22). At RT, the single-layered VO<sub>2</sub> nanomembrane has a low absorbance over the entire spectral range; however, it shows an increase in absorbance with increasing temperature (41). Furthermore, a sharp increase (decrease) in the absorbance of VO<sub>2</sub> can be observed during heating (cooling), which is consistent with the behavior of resistance changing during VO<sub>2</sub> phase transition (fig. S23). The temperature-dependent absorption characteristics of the double-layered VO<sub>2</sub> nanomembrane are coherent with the single-layered VO<sub>2</sub> nanomembrane (fig. S24), but the absorbance is about twice of the single-layer VO<sub>2</sub> nanomembrane (fig. S25). The low absorbance of the planar VO<sub>2</sub> nanomembrane results in the unquestionably low detection performance of infrared photodetectors (figs. S26 and S27). Similarly, there is also a temperature-dependent absorbance in the tubular VO<sub>2</sub> nanomembrane, and the temperature at which the absorbance decreases drastically is consistent with the phase transition temperature of the tubular VO<sub>2</sub> nanomembrane (fig. S28). The absorbance of the tubular VO<sub>2</sub> nanomembrane was greatly improved across the entire spectrum. The phase transition temperature of the VO<sub>2</sub> nanomembranes decreases when subjected to compressive strain. To clearly demonstrate that the increased absorbance of the tubular VO<sub>2</sub> nanomembrane is mainly due to its tubular geometry, we present the absorbance of planar single-layer VO<sub>2</sub> nanomembrane, curved single-layer VO<sub>2</sub> nanomembrane, and single-walled VO<sub>2</sub> tube at RT in Fig. 4A. The absorbance calculated by Lambert Beer's law exceeds 1, which means that the actual absorbance exceeds 90% (42). Compared with the planar VO<sub>2</sub> nanomembrane, the absorbance of the curved VO<sub>2</sub> nanomembrane is almost doubled, while the absorbance of the tubular VO<sub>2</sub> nanomembrane in the long-wave infrared is more than 20 times higher, as shown in Fig. 4B.



**Fig. 3. Metal-insulator phase transition of the VO<sub>2</sub> nanomembranes driven by temperature and voltage.** Schematic diagram of unreleased (**A**), released (**B**), and rolled-up (**C**) VO<sub>2</sub> nanomembranes on chips. (**D**) Current-voltage characteristic curves of the unreleased VO<sub>2</sub> nanomembrane device under different heating temperatures. VO<sub>2</sub> nanomembranes are semiconductor at 25° and 60°C and metal at 70° and 80°C. Current-voltage characteristic curves of the released (**E**) and rolled-up (**F**) VO<sub>2</sub> nanomembranes measured at RT. The lower curves show the absolute value of the current-voltage slope. (**G**) Current of unreleased VO<sub>2</sub> nanomembranes at 0.1 V at different temperatures. A sudden change in current between 65° and 70°C indicates metal-insulator phase transition in the VO<sub>2</sub> nanomembrane.  $V_{MIT}$  of freestanding (**H**) and rolled-up (**I**) VO<sub>2</sub> nanomembranes as a function of heating temperature.

Figure 4C shows the electrical properties of a VO<sub>2</sub> microtube. During full cycles of voltages from 0 to 3 V and 3 to 0 V, VO<sub>2</sub> transitions from monoclinic to rutile and then back to monoclinic. The phase change voltage is between 1 and 1.5 V. To analyze the noise sources of the device, we measured the current noise in the dark current, as shown in Fig. 4D. The results show that generation-recombination (G-R) noise and 1/f noise are the main noise sources for this device at low and high frequencies, respectively (43, 44). In addition, the current noise of the device increases with increasing applied bias voltage (fig. S29), which is probably due to the Joule heat generated at high voltages. To characterize the response time of the bolometer, frequency-dependent measurements of the photocurrent increment were performed and the results are shown in Fig. 4E. Low-frequency devices are affected by G-R noise resulting in a trend of  $I_p \sim 1/f^2$ , when the photocurrent of the device at high frequency is dominated by 1/f noise. The photoresponse current  $R_I(\omega)$  can be explained and approximated (45) by  $R_I(\omega) = F(\omega)/2$  $\sqrt{(1 + \tau^2 \omega^2)}$ , where  $F(\omega)$  is a rational polynomial term, mainly related to the thermal propagation characteristics of VO<sub>2</sub>, and  $\omega$ is the modulation frequency. We get a response time constant  $\tau =$ 14.9 ms, and the tubular VO<sub>2</sub> bolometer exhibits a noise equivalent power of 1.79 nW/ $\sqrt{\text{Hz}}$  and a calculated NETD of 64.6 mK (note S2). Figure 4F shows the temporal response of the photocurrent under laser illumination of different wavelengths. The

Figure 4G shows that the detectivity  $(D^*)$  of the bolometer is calcu- $\frac{R}{\sqrt{\left(\frac{4k_{\rm b}T}{R^{\prime}a}+\frac{2eI_{\rm dark}}{A}\right)}}$ , where *e* is the unit lated with the formula (46, 47)  $D^* =$ charge, R' is the bias resistance, A is the effective area of the device,  $I_{\text{dark}}$  is the dark current, and R is the photoresponsivity, and no wavelength-selective properties are observed. The calculated average detectivity is  $\sim 2 \times 10^8$  cm Hz<sup>0.5</sup> W<sup>-1</sup>, which is slightly overestimated for lacking consideration of 1/f noise. Figure 4H shows the peak detectivity of commercially available high-performance HgCdTe detectors, the emerging InAs/InAsSb superlattice, and several typical thermal detectors. Compared with long-wave infrared detectors operating at RT, our tubular bolometers have performance advantages, but are slightly inferior to photon detectors and superconducting bolometers operating at low temperatures. In the long-wavelength infrared range, the theoretical performance limit of thermal detectors is closest to that of photon detectors. With further optimization, the microtube bolometer could be a very promising structural paradigm to help thermal detectors bridge the performance gap to photon detectors.

corresponding rise and decay times are 3.1 and 1.7 ms at 520 nm,

1.8 and 1.4 ms at 1650 nm, and 2.3 and 2.1 ms at 4600 nm (fig. S30).

The performance merits of a tubular  $VO_2$  bolometer are further demonstrated and compared to typical commercially available longwavelength infrared photodetectors. The tubular geometry is anisotropic to the electric vector of electromagnetic waves, like nanowires



**Fig. 4. Photoresponse performance of tubular VO<sub>2</sub> bolometers. (A)** Absorbance of planar VO<sub>2</sub> nanomembrane, curved VO<sub>2</sub> nanomembrane, and single-walled VO<sub>2</sub> microtubules at RT, including fluctuations in the absorption of CO<sub>2</sub> and H<sub>2</sub>O in air. The absorption of CO<sub>2</sub> and H<sub>2</sub>O in the atmosphere caused fluctuations of 2375 to 2350 cm<sup>-1</sup> and 1750 to 1200 cm<sup>-1</sup>, respectively. (**B**) Increase in absorbance of curved VO<sub>2</sub> and tubular VO<sub>2</sub> relative to planar VO<sub>2</sub>. (**C**) Current-voltage characteristics of a multi-turn VO<sub>2</sub> microtube and voltage-driven metal-insulator phase transition. Inset is a ball-and-stick model of monoclinic (rutile) VO<sub>2</sub> at low voltage (high voltage). (**D**) Current noise of a tubular VO<sub>2</sub> bolometer varied with frequency (*f*). The device is measured at RT, and the voltage is set as 0.5 V. (**E**) Photocurrent response dependence of the bolometer as a function of frequency (*f*). (**F**) Response time of the device under 520-, 1650-, and 4600-nm laser illumination with *V* = 0.5 V. (**G**) Detectivity of the tubular VO<sub>2</sub> bolometer as a function of the wave number, and the voltage is set as 0.5 V. The detectivity is up to ~2 × 10<sup>8</sup> cm Hz<sup>0.5</sup> W<sup>-1</sup> in ultrabroad infrared spectrum. (**H**) Detectivity comparison of the tubular VO<sub>2</sub> bolometer with other long-wavelength infrared photodetectors. The background-limited infrared performance (BLIP) of photovoltaic and thermal infrared photodetectors at 8 µm is shown by dashed-dotted lines. HgCdTe, InAs/InAsSb, and YBaCuO work at low temperatures, as indicated in the figure.

(48), which has the potential for polarized light detection without assistance of optical lenses. The test setup illustrated in Fig. 5A was used to study the polarization-dependent response. Figure 5B shows the relationship between the photocurrent and polarization angle of the tubular bolometer. The angle of incoming polarized light causes a periodic variation in the photocurrent. The dichroic ratio of the tubular devices can be obtained by using a fitting function to determine the device's capacity for polarization detection. Under 4600nm light, the tubular bolometer exhibits a dichroic ratio of 1.17. In addition, the tubular geometry also provides an opportunity for wide-angle detection from the direction that is perpendicular to the tube axis (24). Figure 5C is a schematic diagram of an axial section of the tube with a 520-nm laser irradiated on the tube at

an angle of  $\theta_1$ . By rotating the laser (fig. S31), the tubular bolometer presents an angle-independent photocurrent within  $-75^\circ$  to  $75^\circ$ , as shown in Fig. 5D. The simulation results show that the VO<sub>2</sub> microtubes can also trap light with incident angles of 90°, 60°, 45°, and 30° (fig. S32). Figure S33A is a schematic vertical axial cross-sectional view of the tube where the laser is irradiated on the tube at an angle  $\theta_2$ . By measuring photocurrent via rotating the laser around the tube, the tubular bolometer exhibits a pronounced angle-dependent photocurrent omnidirectionally, as shown in Fig. 5D, which is consistent with the angle-dependent properties of planar devices, and the photocurrent can be explained by the formula  $I_p = I_{p,\theta=90^\circ} \times \cos \theta_2$  (fig. S33B). However, the tubular geometry still retains the trapping effect for light (fig. S34).



**Fig. 5. Polarization and omnidirectional detection characteristics of 3D tubular bolometers.** (**A**) Schematic of a tubular VO<sub>2</sub> bolometer irradiated by polarized light. (**B**) Photocurrent as a function of the polarization angle of incident light. The wavelength is 4600 nm. The solid line represents fitting using a sinusoidal function  $I_{ph}(\delta) = I_{py} \cos^2(\delta + \varphi) + I_{px} \sin^2(\delta + \varphi)$ . The fitted dichroic ratio is 1.17. (**C**) Schematic cross section of a tubular VO<sub>2</sub> bolometer irradiated by light at an angle  $\theta_1$  along the direction perpendicular to the tube axis. (**D**) Angle-independent photocurrent at different light incident angles. (**E**) Comparison of the acceptance angle and effective sensor area of our tubular VO<sub>2</sub> bolometer to commercially available HgCdTe (photovoltaic) and pyroelectric (thermal) detectors.

Long-wavelength infrared is often used for safety prevention and control in civilian fields, such as emergency search and rescue and forest fire prevention. The detection distance of long-wave detectors can reach kilometers or more, but the viewing angle is often limited by the optical lens and its own area. Therefore, it is of far-reaching significance to realize wide-angle detection to broaden the observation range of infrared detectors. Figure 5E shows a comparison of acceptance angle and effective sensor area to other advanced commercially available infrared detectors. Our tubular bolometer enables large detection angle in a small footprint. A bolometer with a tubular geometry holds great promise for wide-angle and broad-spectrum polarization photodetection at RT.

#### DISCUSSION

We have designed and fabricated a proof-of-concept device architecture—tubular  $VO_2$  bolometers by a one-step rolling approach. The introduction of tubular geometry into nanomembrane bolometers improves thermal insulation, enhances light absorption, and enables polarization-sensitivity and omnidirectional light detection. In addition, the compressive strain reduces the metal-insulator phase transition temperature of VO<sub>2</sub>, making the rolled-up VO<sub>2</sub> nanomembrane more sensitive to thermal signals. For an emerging structural paradigm of bolometers, the detectivity of  $2 \times 10^8$  cm Hz<sup>0.5</sup> W<sup>-1</sup>, response times of ~2.0 ms, and calculated NETD of 64.5 mK are excellent starting points for further improving the performance of tubular device by optimizing material quality, 3D packaging, etc. Our tubular bolometer is a pioneering integrated sensing device, and it opens the possibility to explore numerous applications in the long-infrared region with tubular device structure and design, which will potentially change the current civil infrared market landscape.

#### **MATERIALS AND METHODS**

### Growth of VO<sub>2</sub> nanomembranes and fabrication of tubular VO<sub>2</sub> bolometers

The 4-inch silicon substrate covered with 500-nm SiO<sub>2</sub> was cleaned with acetone and deionized water. VO<sub>2</sub> nanomembranes are sputtered on silicon substrate by magnetron sputtering at 500°C for 700 s in argon-oxygen flux. The argon-oxygen ratio is 36:60, and the sputtering power is 200 W. The electrodes were defined by photolithography (HEIDELBERG, UPG501), and Cr was deposited by electron beam evaporator. The etching window is etched by RIE for 100 s [30 standard cubic centimeters per minute (sccm) Ar and 30 sccm CF<sub>4</sub> flow, 300 mtorr chamber pressure, and 100 W etching power]. The VO<sub>2</sub> nanomembranes were released and rolled up in 10% hydrofluoric acid solution for 3 min. Last, the rolled-up microtubes are dried in a critical point drying (Leica CPD030 Critical Point Dryer).

#### Material characterizations

A LabRam HR800 from HORIBA spectrometer and heating stage (Linkam LTSE420) were used for Raman measurements. VO<sub>2</sub> nanomembranes were also characterized by XRD (Bruker D8 DISCOV-ER). The absorbances of VO<sub>2</sub> nanomembranes were measured by FTIR spectroscopy (Thermo Fisher Scientific, Nicolet IS5, BRUKER TENSOR II). The morphologies of VO<sub>2</sub> tubes were first characterized by scanning electron microscopy (SEM; JEOL JSM-6701F), and the TEM and EDS measurements were performed by JEOL JEM2100F TEM with EX-24063JGT EDS.

#### Electrical and optoelectronic characterizations

The electrical measurements were performed by using a commercial KEYSIGHT B2902B at RT and under ambient conditions. The measurement of photocurrent was carried out with a modulated laser beam, and the photocurrent signal was acquired by a lock-in amplifier (Stanford SR830) and a current amplifier (Stanford SR570). Polarized photocurrent measurement was taken by an MStarter 200 optoelectronic measurement system from Maita Optoelectronic Technology Co. Ltd. In the polarization test, the linearly polarized light is focused onto the upper surface of the selfrolled VO<sub>2</sub> microtubes through the lens, and the substrate is not exposed to light. During the test of omnidirectional detection, a large laser light spot completely covers the VO<sub>2</sub> microtubes and part of the substrate. The noise was measured by a noise measurement system (PDA NC300L, 100-kHz bandwidth).

#### Thermal and optical simulation

The thermal simulation was realized by COMSOL Multiphysics, in which we considered the heat flow from incident laser as a Gaussian function distribution heat source that is vertical to the substrate. Because the spot radius of laser (~mm) is far larger than the size of microtube (~µm), the laser can be considered as uniformly distributed on microtube with power of 1 mW to obtain the transient thermal response of the device. As for solid, the energy conservation equation can be written as

$$\rho C_{\rm p} \left( \frac{\partial T}{\partial t} + u \cdot \nabla T \right) = \nabla \cdot (k \nabla T) + W_{\sigma} + Q \tag{1}$$

where  $\rho$  is the density,  $C_p$  is the heat capacity at constant pressure, T is the temperature, k is the thermal conductivity, t is the time, u is

the displacement,  $W_{\sigma}$  is the heat source generated by solid compression or expansion during temperature change, and Q is the heat absorbed by the system. During the heating process, the temperature changes of tube and substrate are relatively small, and the coefficient of thermal expansion  $\alpha$  is about  $10^{-5}$ , so  $W_{\sigma}$  in the process is negligible. The equation is then simplified to

$$\rho C_{\rm p} \left( \frac{\partial T}{\partial t} + u \cdot \nabla T \right) = \nabla \cdot (k \nabla T) + Q \tag{2}$$

Optical simulation of VO<sub>2</sub> nanomembranes was performed on the basis of the finite element method by using FDTD approach to exhibit the light trapping in VO<sub>2</sub> tube. The incident light is considered as plane wave, with wavelengths from 1 to 10  $\mu$ m and a step of 1  $\mu$ m. The boundary condition of substrate side and its opposite side was set as perfectly matched layer, while boundary condition of other two sides that is vertical to substrate was set as periodic because the tubes are identical in the tube arrays. The wave equation of plane wave can be written as

$$\nabla \times (\nabla \times E) - k_0^2 \varepsilon_{\rm r} E = 0 \tag{3}$$

where *E* is the electric field,  $k_0$  is the imaginary part of refractive index, and  $\varepsilon_r$  is the relative dielectric constant. The relative dielectric constant is calculated by

$$\varepsilon_{\rm r} = (n - {\rm i}k)^2 \tag{4}$$

where n is the refractive index and k is the extinction coefficient.

#### **Supplementary Materials**

This PDF file includes: Figs. S1 to S34 Table S1 Notes S1 and S2 References

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## **Science**Advances

## One-step rolling fabrication of $\mathrm{VO}_2$ tubular bolometers with polarization-sensitive and omnidirectional detection

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